



Docket No. N1085-00261
Inventors: Wan-Cheng Yang
"In-Line Wafer Surface Mapping"
Sheet 1 of 8

BEST AVAILABLE COPY

FIGURE 1A

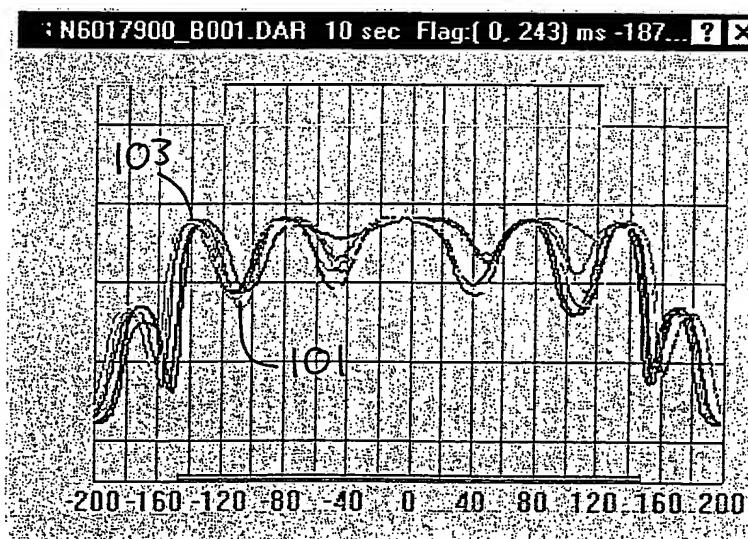
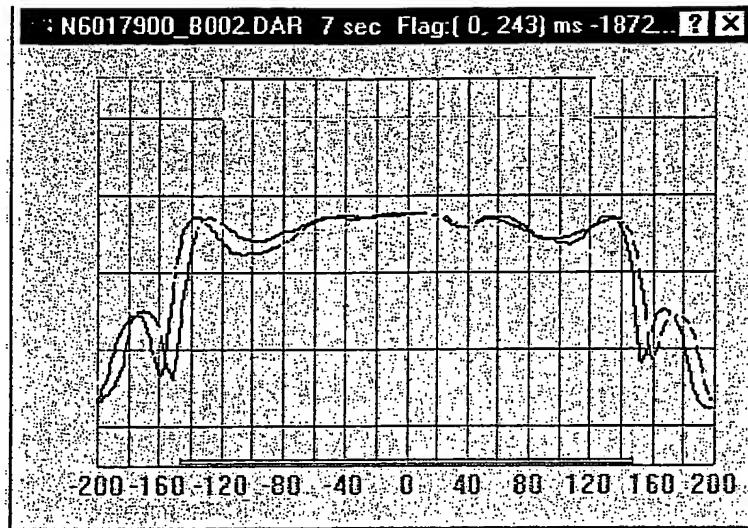
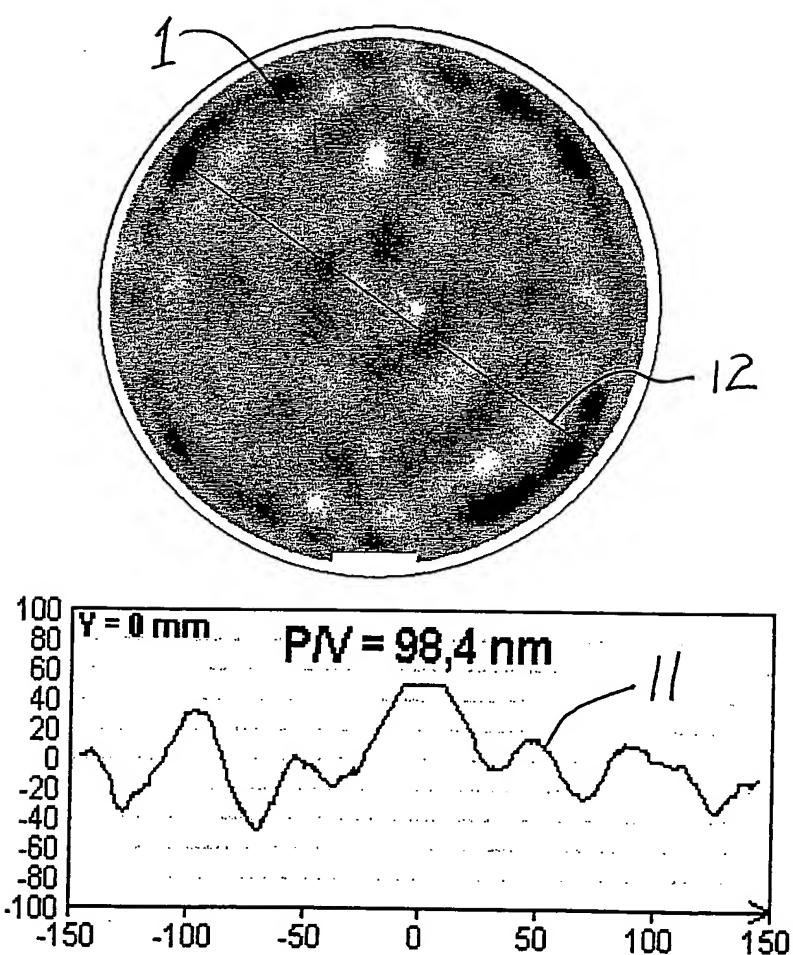


FIGURE 1B

FIGURE 2



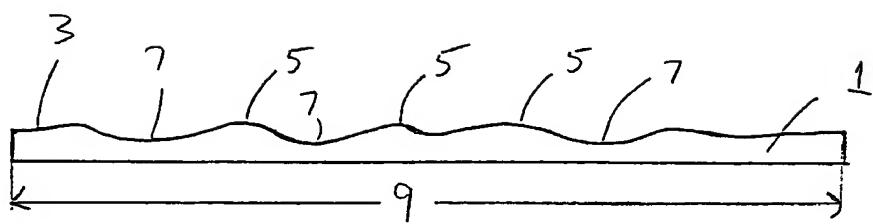


FIGURE 3.

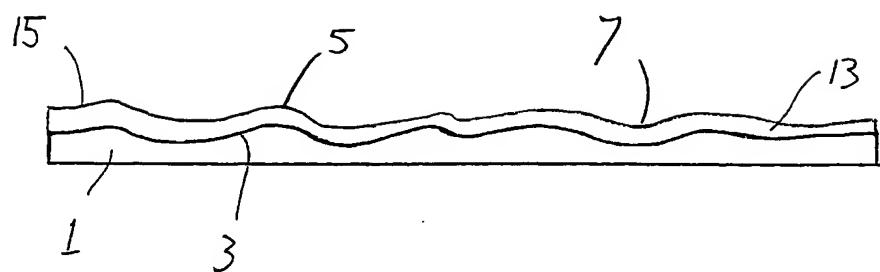


FIGURE 4



FIG 5

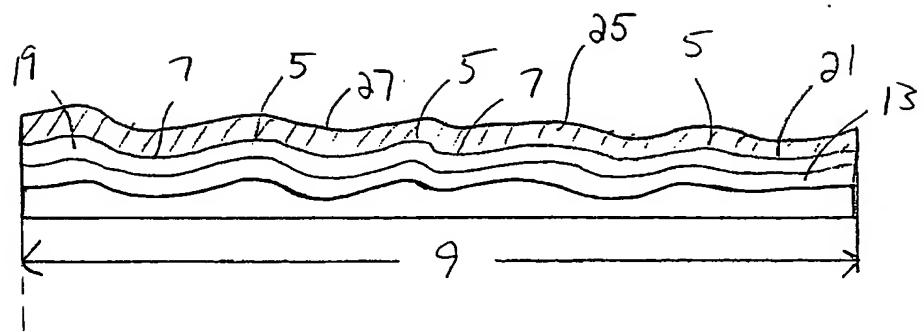


FIG 6

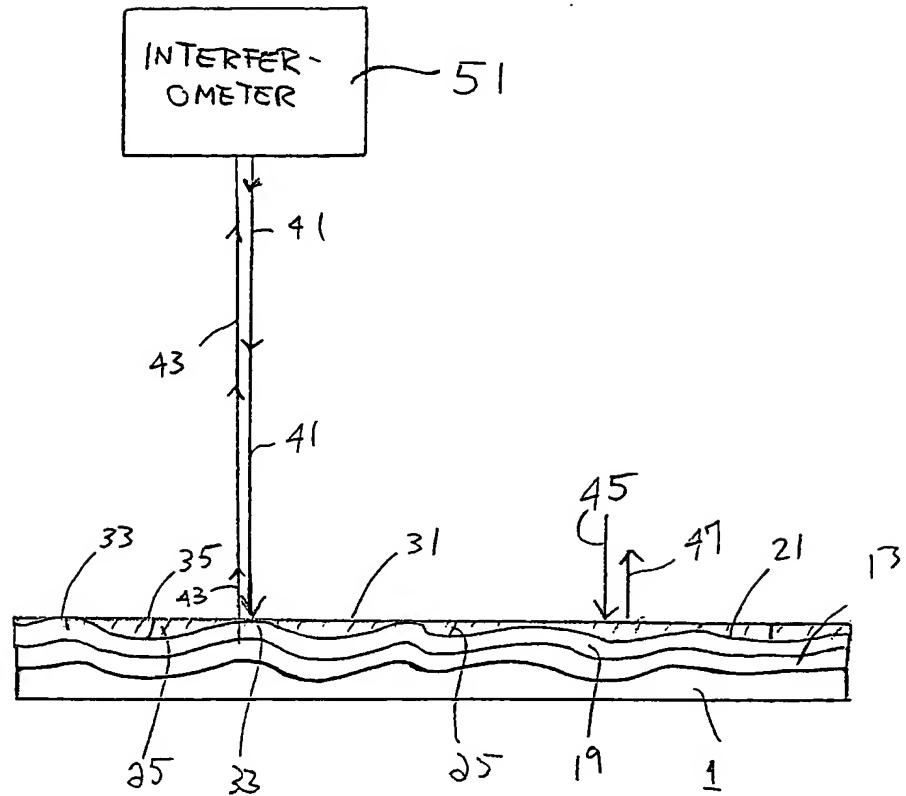


FIGURE 7

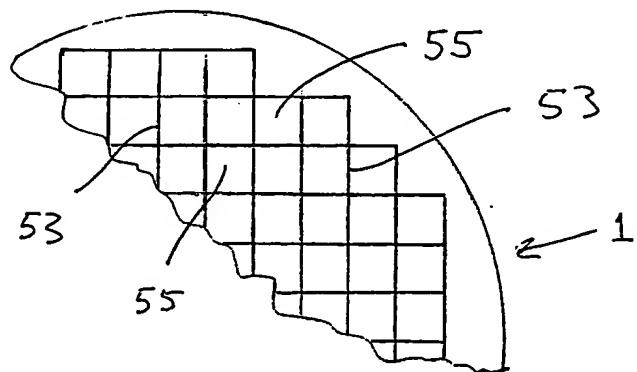


FIGURE 8

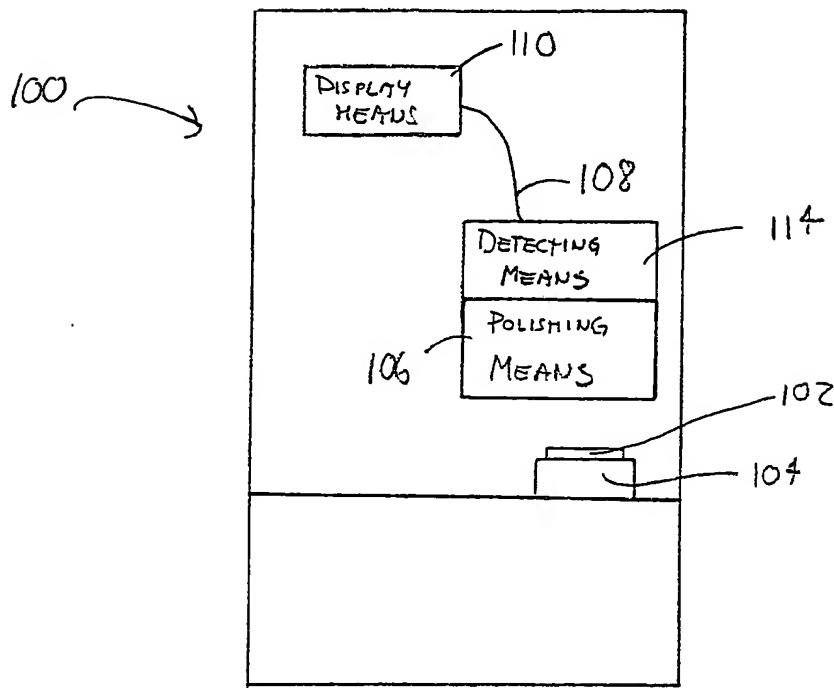


FIGURE 9